

Appl. No.: 10/814,697  
Confirmation No. 7228  
Applicant: Xiaolei Shi et al.  
Filed: 30 March 2004  
Title: NEAR FIELD OPTICAL STORAGE MASK LAYER, DISK, AND FABRICATION METHOD  
TC/A.U.: 1756  
Examiner: Verderame, Anna L

Docket No.: 140264-1  
Customer No.: 6147

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 CFR 1.111**

In response to the Office action of 18 June 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.